

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Jaiswal	Docket No.: TI-34403.1
Serial No.: TBD	Examiner: TBD
Filed: 10/6/2003	Art Unit: TBD
For: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF PLASMA SPUTTER ETCH	

PRELIMINARY AMENDMENT

Honorable Assistant Commissioner
of Patents
Washington, D.C. 20231

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Date of Deposit: October 6, 2003.

Prior to the examination of the above identified application, please amend the above referenced Application as follows: